



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **SHIMOYAMA, et al.**

Group Art Unit: **2814**

Serial No.: **09/785,428**

Examiner: **WILLE**

Filed: **February 20, 2001**

P.T.O. Confirmation No.: 1962

For: **SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 22, 2003

Sir:

In response to the Office Action dated **March 18, 2003**, please amend the above-identified application as follows:

RECEIVED
SEP 29 2003
TECHNOLOGY CENTER 2800